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Docket No. F-8601

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1795**

DO NOT ENTER: /WL/ (09/10/2010)

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AUG 30 2010****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Hideo YOSHIDA, et al.  
Serial No. : 10/526,205  
Filed : March 1, 2005  
For : ANODIC OXIDATION METHOD, TITANIUM OXIDE  
FILM MANUFACTURING METHOD AND  
CATALYST CARRYING METHOD  
Group Art Unit : 1795  
Examiner : William T. Leader  
Confirmation No. : 4976  
Customer No. : 000028107

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(Name)

  
(Signature)

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Commissioner for Patents  
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**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Sir:

In response to the final Office Action of April 29, 2010, entry of the  
present amendment effecting claim amendments to place the application in

(1601 smd) rtp to 2010-04-29 fax (PCX) 1 - wpl